

FIG. 1

PRIOR ART

2. BUFFER TANK

3. PUMP

4. FILTER

5. EJECTION VALVE

6. SUCK-BACK FILTER

7. NOZZLE PIPE

8. NOZZLE TIP

100. SEMICONDUCTOR SUBSTRATE

FIG. 2

100. SUBSTRATE

CUP

FIG. 3

A. AIR BUBBLE

B. PHOTORESIST LIQUID

FIG. 4

A. AIR BUBBLE

FIG. 1
PRIOR ART

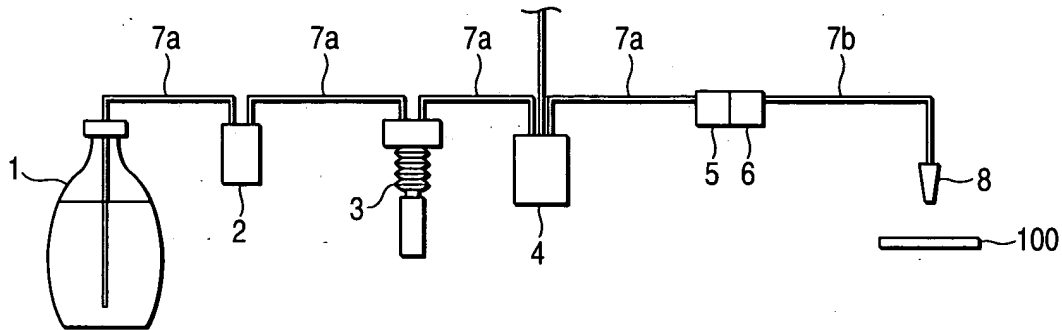


FIG. 2

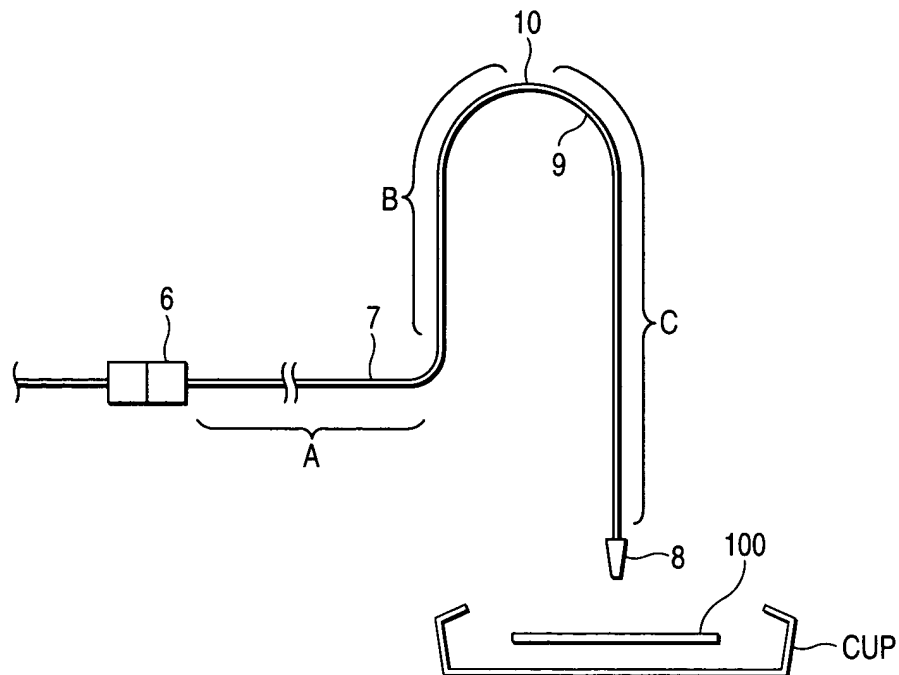


FIG. 3

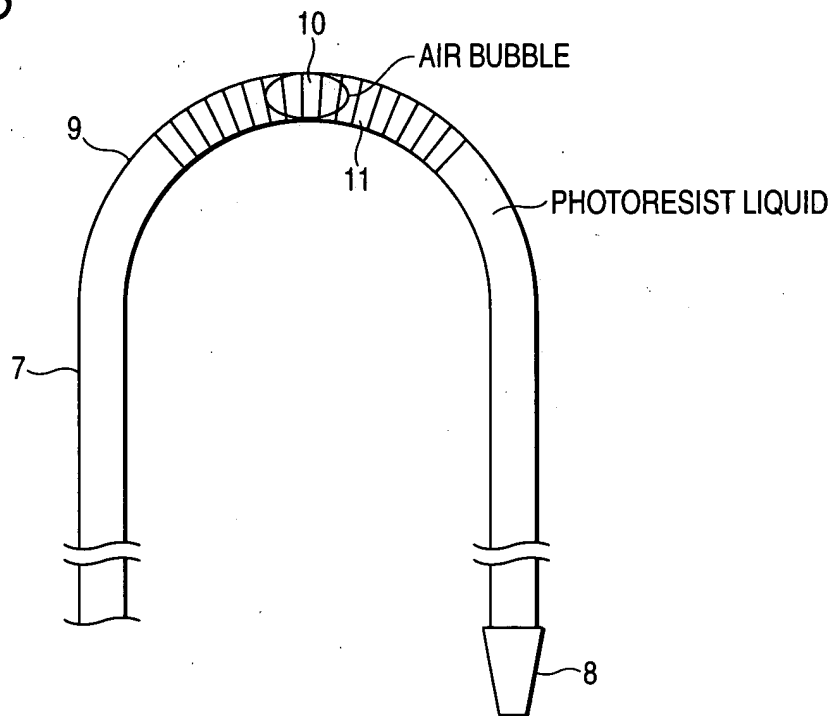


FIG. 4

